

**FORM PTO-1449
INFORMATION DISCLOSURE
STATEMENT BY APPLICANT(S)**

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Applicants : T. YAMAMOTO et al.
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Group Art Unit :
Examiner :

U.S. PATENT DOCUMENTS

Examiner Initial	Patent Number	Patent Date	Name	Class/ Subclass	Filing Date
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FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class/ Subclass	Translation Yes No
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OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

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1. IEEE TRANSACTIONS ON MAGNETICS, Vol. 35, No. 5, Sep. 1999; Y. Matsuda et al.: *Noise Reduction by Surface Oxidization of a CoCrZr Seed layer on Glass Substrates for CoCrPt/CrTi Thin Film Media*, pp. 2640, 2642

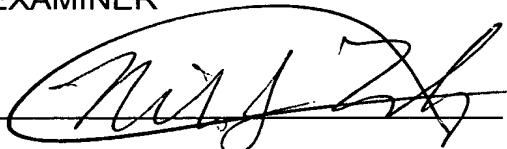
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2. IEEE TRANSACTIONS ON MAGNETICS, Vol. 30, No. 6, Nov. 1994; Li-Lien Lee et al.: *NiAl Underlayers For CoCrTa Magnetic Thin Films*

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3. IEEE TRANSACTIONS ON MAGNETICS, Vol. 33, No. 5, Sep. 1997; Y. Hosoe et al.: *Experimental Study of Thermal Decay in High-Density Magnetic Recording Media*

EXAMINER



DATE CONSIDERED

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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.